

<b>Notice of References Cited</b>	Application/Control No. 10/020,872		Applicant(s)/Patent Under Reexamination CHEON LEE, BYUNG	
	Examiner Andrew C. Lee		Art Unit 2616	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,594,267	07-2003	Dempo, Hiroshi	370/395.64
*	B	US-2003/0026266	02-2003	Choi, Sang Jun	370/395.64
*	C	US-6,747,974	06-2004	Hayashi, Kentaro	370/395.1
*	D	US-6,574,224	06-2003	Brueckheimer et al.	370/395.6
*	E	US-6,931,012	08-2005	Karlsson et al.	370/395.31
*	F	US-6,434,151	08-2002	Caves et al.	370/395.2
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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